

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Int. Appl No.: PCT/AU2003/001313 )

Applicant: Aberle, Armin Gerhard )

Filed: October 7, 2003 )

Title: FABRICATION METHOD FOR  
CRYSTALLINE  
SEMICONDUCTOR FILMS ON  
FOREIGN SUBSTRATES )

Group Art  
Unit: Not Yet Assigned )

Examiner: Not Yet Assigned )

Docket No.: 85267 )

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**PRELIMINARY AMENDMENT**

Mail Stop PCT  
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Sir:

Prior to examining the above-identified U.S. national phase application of International patent application No. PCT/AU2003/001313, having a priority date of October 8, 2002, please amend the above-identified application as follows:

**Amendments to the Specification** begin on page 2 of this paper.

**Amendments to the Claims** are reflected in the listing of claims with begins on page 4 of this paper.

**Remarks/Arguments** begin on page 10 of this paper.